SHEET 1 OF ATTY DOCKET NO. SERIAL NO. Form PTO 1449 (Modified) U.S. DEPART OF COMMERCE PATENT AND 212740US-2SRD CON) **New Continuation App** APPLICANT LIST OF REFERENCES CITED BY APPLICANT Yoshiyuki MATSUNAGA, et al. GROUP FILING DATE Herewith Unassigned **U.S. PATENT DOCUMENTS EXAMINER** DOCUMENT **SUB** FILING DATE DATE CLASS NAME INITIAL NUMBER **CLASS** IF APPROPRIATE AA 4.819.070 04/04/89 Hynecek 5,144,447 AB 09/01/92 Akimoto, et al. AC 4,809,075 02/28/89 Akiomoto, et al. AD 5,172,249 12/15/92 Hashimoto AF 4,942,474 07/17/90 Akimoto, et al. AF 4,926,247 05/90 Nagasaki, et al. 5,138,458 AG 08/92 Nagasaki, et al. AH 5,335,075 08/94 Komiya, et al. Al 5,402,171 03/95 Tagami, et al. A.J 5,343,254 08/94 Wada, et al. ΑK RE 34,926 05/95 Hieda, et al. AL 5,625,411 04/97 Inuiya, et al. AM 4.805.025 02/89 Akiyama, et al. 01/96 AN 5,488,415 AO 6,091,449 07/00 Matsunaga, et al ΑP 5,379,068 01/95 Hamasaki AQ 5,793,423 08/98 Hamasaki AR 5,187,583 02/93 Hamasaki AS 5,322,994 06/94 Uno AT 5,296,696 03/94 Uno **FOREIGN PATENT DOCUMENTS** DOCUMENT **TRANSLATION** DATE COUNTRY NUMBER YES NO AO 1-245769 09/29/89 Japan X 6-217205 08/05/94 AP Japan Х 1-238381 09/22/89 AQ Japan X AR WO97/07631 02/27/97 WIPO (English Abstract Only) Х AS 5-207220 08/13/93 Japan X AT 62-213485 09/19/87 Japan Х ΑU 6-350886 12/22/94 Japan X ΑV 5-56357 03/05/93 Japan Х 5-37940 02/12/93 Japan X 08/23/96 Japan 61-189785 X OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, etc.) Chamberlain, Savvas G. "Photosensitivity and Scanning of Silicon Image Detector Arrays." IEEE, Journal of Solid-State ΑZ Circuits, Vol. SC-4, No. 6, December 1969, pp. 333-342. Patent Abstracts of Japan, Vol. 18, No. 535 (E-1615), October 12, 1994, JP 06 189199, July 8, 1994. BA вв

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